



RECEIVED

APR 01 2003

AF/1700

TC 1700

AMENDMENT UNDER 37 C.F.R. §1.116
EXPEDITED PROSECUTION - GROUP ART UNIT 1771

03500.014776

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
HIROKATSU MIYATA) Examiner: Hai Vo
Application No.: 09/657,616) Group Art Unit: 1771
Filed: September 8, 2000)
For: MESOSTRUCTURED THIN FILM,)
MESOPOROUS THIN FILM, AND)
PROCESS FOR PRODUCTION)
THEREOF) March 24, 2003

#13/B(Ne)
60
4203

Commissioner for Patents
Washington, D.C. 20231
Box: AF

RESPONSE AFTER FINAL REJECTION

Sir:

In response to the final Office Action dated December 24, 2002, kindly
consider the remarks which follow:

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope addressed
to: Commissioner for Patents, Washington, D.C. 20231 on

March 24, 2003

(Date of Deposit)

PETER SAXON (24947)

(Name of Attorney for Applicant)

Peter Saxon

Signature

March 24, 2003

Date of Signature